



PATENT
Atty. Dkt. No. AMAT/4215/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sun et al.

Serial No.: 09/645,690

Confirmation No.: 4428

Filed: August 24, 2000

For: Cu CMP POLISHING PAD
CLEANING

§§§§§

Group Art Unit: 1746

Examiner: Winter, Gentle E.

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

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CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>November 27, 2002</u> with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.	
<u>11/27/02</u>	<u>[Signature]</u>
Date	Signature

RESPONSE TO OFFICE ACTION DATED AUGUST 27, 2002

In response to the Office Action dated August 27, 2002, having a shortened statutory period for response set to expire on November 27, 2002, please enter the following amendments and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no fee is due in conjunction with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4215/CMP/CMP/WBP for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

IN THE CLAIMS:

Please amend claims 4-5, 10-12 15, and 16.

Please cancel claims 19-25.

Please add new claims 26-32.

Please replace the following claims: